

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date July 15, 2002

In re the Application of

Akira SATO

Application No.: 09/424,500

Filed: February 22, 2000

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, MOLDING DEVICE FOR SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICE



Group Art Unit: 2825

Examiner: G. Lee, Jr.

Docket No.: 104788

Handwritten notes:
#10/Ext(11)
G. Lee
7/26/02

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired June 13, 2002, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 132545 in the amount of \$110.00 in payment for:

<u>XX</u>	Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
<u> </u>	Extension fee for response within second month pursuant to §1.136(a) (\$400.00)
<u> </u>	Extension fee for response within third month pursuant to §1.136(a) (\$920.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

Handwritten signature of Benjamin M. Halpern

James A. Oliff
Registration No. 27,075

Benjamin M. Halpern
Registration No. 46,494

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DEPOSIT ACCOUNT USE
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Please grant any extension
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